

		Application No.	Applicant(s)			
		09/276,868	Simons and Gao			
		Examiner Kam, Chih Min	Group Art Unit 1656	Page <u>2</u> of <u>3</u>		
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#	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
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\* A copy of this reference is not being furnished with this Office action.  
(See Manual of Patent Examining Procedure, Section 707.05(a).)

**Notice of References Cited**

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